

Application No. 09/998,334

REMARKS

In response to the restriction requirement mailed January 10, 2003 Applicant provisionally elects claims 1-8 for prosecution. In addition, Applicant respectfully requests entry of the preceding amendment to the specification of the above referenced patent application.

If the Examiner believes a telephone conference would facilitate prosecution, Applicant respectfully requests that the Examiner contact the undersigned.

Respectfully submitted,



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VERSION WITH MARKINGS TO SHOW CHANGES MADE:

IN THE SPECIFICATION:

Inserted on page 1, line 2 before "Background of the Invention":

STATEMENT OF RELATED APPLICATION

This application is related to U.S. patent application 09/998,294 entitled "Improved Nanotip Structure Formed From Dislocations in a Material" and U.S. patent application 09/998,336 entitled "Method for Fabricating GaN Field Emitter Arrays", both filed on December 3, 2001 and assigned to the same assignee.

IN THE CLAIMS:

Claims 9-13 have been cancelled.